

Notice of References Cited	Application/Control No. 10/047,679	Applicant(s)/Patent Under Reexamination FRIEDMAN ET AL.	
	Examiner Samuel Broda	Art Unit 2123	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-6,240,450	05-2001	Sharples et al.	709/224
X	B	US-6,260,141	07-2001	Park, Hyo Joon	713/155
	C	US-6,275,976	08-2001	Scandura, Joseph M.	717/120
	D	US-5,870,764	02-1999	Lo et al.	707/203
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Kristoff et al, "The Process Specification System for MMST," IEEE Transactions on Semiconductor Manufacturing, Vol. 8 No. 3, pp. 262-271 (August 1995)
	V	Petrie, "The Redux' Server," IEEE Proceedings of the International Conference on Intelligent and Cooperative Information Systems, pp. 134-143 (May 1993)
	W	Courtney et al, "Relating Hierarchy Designs Back to Their Predecessors," IEEE Symposium on Applied Computing, pp. 412-421 (April 1991)
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.